## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Application of :

Toshio KODAMA et al. :

Serial No. (not yet assigned) :

Filed: January 11, 2005

For: ION BEAM APPARATUS, AND

ION BEAM PROCESSING :

METHOD, AND HOLDER : Docker

MEMBER : Docket No. S004-5433(PCT)

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MS PCT COMMISSIONER FOR PATENTS P.O. Box 1450 Alexandria, VA 22313-1450

## PRELIMINARY AMENDMENT CANCELING CLAIMS TO REDUCE FILING FEE

S I R:

Applicants preliminarily amend their application before calculation of the filing fee as follows:

BY EXPRESS MAIL ON JANUARY 11, 2005 (EV 504 368 240 US)